IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shen et al.

Group Art Unit: 1763

Application No: 09/507,629

Examiner: Allan W. Olsen

Confirmation No: 7912

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001945 USA P03/ETCH/SILICCIN/JB1

Title: SELF-CLEANING PROCESS FOR ETCHING SILICON-CONTAINING

March 10, 2003

MATERIAL

San Francisco, California

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Assistant Commissioner for Patents Washington, D.C. 20231

<u>Via Facsimile Transmission</u> (703) 872-9310

Examiner Olsen:

This communication is in response to the Office Action mailed on December 10, 2002, and is being timely filed within three months thereof.

Certificate of Transmission

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Date March 10, 2003

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